



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1762
Examiner : M. Cleveland
Serial No. : 09/125,128
Filed : August 11, 1998
Inventors : Yuichiro Iguchi
: Masahiro Matsumoto
: Yuko-Mikami
: Takaki Masaki
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Title : A METHOD AND APPARATUS
: FOR PRODUCING A
: PLASMA DISPLAY

36th Floor
1600 Market Street
Philadelphia, PA 19103

Docket: 1084-98

#11/B
01/03/00

Dated: December 21, 2000

AMENDMENT

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

In response to the Official Action dated June 21, 2000, kindly amend the Application as follows:

In the Specification

On page 1, line 19, please change "Prior Arts" to --The Prior Art--.

In the Claims

1. (Amended) A method for producing a plasma display, comprising the step of continuously applying a phosphor paste containing a phosphor powder and an organic compound onto a substrate with a plurality of barrier ribs, from a paste applicator with a plurality of outlet holes, to form a phosphor layer, wherein the lateral side wall thickness (T1) of the phosphor layer at the position corresponding to a half of the height of each barrier rib and the bottom wall thickness (T2) of the phosphor layer satisfy the following relation:

$10 \leq T1 \leq 50 \mu m$

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